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Inventor(s): James E. Moon et al.

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Art Unit: 1746

Filed: November 02, 2001

Examiner: Not Yet Assigned

Title: **METHOD FOR FABRICATING MEMS AND MICROFLUIDIC DEVICES
USING SMILE, LATENT MASKING, AND DELAYED LOCOS TECHNIQUES**

Assistant Commissioner for Patents
Washington, DC 20231

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AMENDMENT

On Page 1 of the specification, please amend the title of the patent application identified
above to METHOD FOR FABRICATING MEMS AND MICROFLUIDIC DEVICES USING
SMILE, LATENT MASKING, AND DELAYED LOCOS TECHNIQUES.

This amendment is submitted to render the title of the invention consistent with the title
submitted by Applicants on Applicants' transmittal papers accompanying the application as filed.

April 18, 2003
Date

Respectfully submitted,

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